

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the National Phase Application in the United States  
of International Patent Application No. PCT/US05/003643  
Filed February 4, 2005

Application No. (To Be Assigned)  
Filing Date: (To Be Assigned)  
Applicant: Paul R. Henion  
Group Art Unit: (To Be Assigned)  
Examiner: (To Be Assigned)  
Title: MIRROR RETENTION SYSTEM  
Attorney Docket: SCH-00084-US2

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT**

Sir:

Prior to examination of the present application, please consider the following.

Please amend the above-identified application as follows.

**Amendments to the Specification** begin on Page 2 of this paper.

**Remarks** begin on Page 3 of this paper.